

PATENT  
2342-111P

IN THE U. S. PATENT AND TRADEMARK OFFICE

APPLICANT: Kazuyuki TOYODA et al. O P T E JC68  
APPL. NO.: 08/905,971 JAN 03 2000 GROUP: 1763  
FILED: August 5, 1997 EXAMINER: R. Zervigon  
FOR: SUBSTRATE PROCESSING APPARATUS

**REPLY UNDER 37 C.F.R. §1.111**

**Assistant Commissioner for Patents  
Washington, D.C. 20231**

Date: January 3, ~~1999~~<sup>2000</sup> (Monday)

Sir:

In response to the Final Office Action dated July 1, 1999, the period for response having been extended for three (3) months to January 3, 2000, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

## IN THE SPECIFICATION:

Please amend the specification as follows:

Page 4

Line 18, before “first” insert --a--; replace “means” with --device--;

Page 5

Line 18, before “second” insert --a--;

Line 19, replace “means” with --device--;

Line 26, before “first” insert --a--; replace “means” with --device--;